

Interference Search History

MT

| Ref # | Hits | Search Query | DBs | Default Operator | Plurals | Time Stamp |
|-------|------|---|---|------------------|---------|------------------|
| L5 | 1 | (semiconductor near connection and electrical near connection and active near areas and conductive near layer and channel).CLM. | US-PGPUB; USPAT; USOCR; EPO; JPO | OR | OFF | 2005/12/01 13:12 |